#### GATE Simulation study @Subatech

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#### Purpose of stay



- 1. Modify GATE code to record hit information in LXe
- 2. Change the geometry to new one designed in Subatech (1" PMT case and 2" PMT case)
- 3. Analyze the results of new set up by previous method and hit information in LXe
- 4. Study the case angle of  $\boldsymbol{\gamma}$  is uniform
- 5. Study compton event
- 6. Study two  $\gamma$  (back-to-back) and 3rd  $\gamma$  event (Future)

# Modify GATE code



- In order to record the hit information in liquid Xenon, I made "lxeHits" Tree. (version 7.0 (newest) was modified)
  - register the liquid xenon to sensitive detector as "LXeSD"
  - includes many "Branch" (histogram) e.g. posX, posY, posZ, eventID..















- Nb of Photon
  - GATE can not simulate the electric field and the material of 2" PMT photocathode is not known in detail.

(Patent of HAMAMATSU)

- Scintillation yield includes these effect to simulate how many number of photoelectrons are detected by PMTs
  - (It does not include some fluctuation, e.g. electric noise.)

2" PMT (1" PMT)

# $\frac{1.0 \times 10^6}{21.6} \times 0.3482(0.3) \times 0.3 \cong 4836(4167)[/MeV]$

Scintillation yield of Xe Q.E. Electric field Scintillation yield for simulation



- Mesh cathode
  - Repeat the wire along x and y axis



Divide the repeaters to 18 areas to approximate the shape to circle



#### Define surface



- Parameter of reflection
  - Teflon
    - Reflectance : 95 [%]
    - Component : Diffuse
  - SUS304

• Reflectance : 6.5 [%] 
$$\left(\frac{n_a - n_b}{n_a + n_b}\right)^2 n_a = 2.36$$
 (RINDEX of SUS304)  
- Calculated  $n_a + n_b^2 n_b^2 = 1.615$  (RINDEX of LXe)

- Component : Specular lobe
- Copper
  - Reflectance : 23 [%]
    - reference : http://www-sk.icrr.u-tokyo.ac.jp/xmass/prelist/2004AutumnTomita.pdf
  - Component : Specular lobe

#### Simulation



- Simulation 1
  - $\theta = 35, 60, 85$  [degree]
  - $-\phi = 90$  [degree]
  - Point source (sphere r = 0.5 [cm])
  - 20 kBq x 0.5[s] = 10000 [event]
  - Only photoeletric event
- Simulation 2
  - $\theta = 35 85$  [degree] (isolated)
  - $\phi = 90 [degree]$
  - Point source (sphere r = 0.5 [cm])
  - 20 kBq x 5.0 [s] = 100000 [event]
  - Only photoeletric event





- Coordinate
  - R is radius of photocathode surface
  - R = 225 [mm]

$$u = z$$
$$v = R \times \arctan\left(\frac{y}{x}\right)$$
$$w = R - \sqrt{x^2 + y^2}$$





- Analysis 1 (previous method) for simulation 1
  - Calculate the mean of u and v by center of gravity method





q<sub>i</sub> : nb of photoelectron
detected by PMT(i)

$$q = \sum_i q_i$$

– Calculate  $\sigma_{<\nu>}$  and  $\sigma_{<\nu>}$  in each D parameter (depth)

$$D = \frac{\sum_{i} q_i \cdot u_i^2 + \sum_{j} q_j \cdot v_j^2}{q} - \left(\frac{\sum_{i} q_i \cdot u_i + \sum_{j} q_j \cdot v_j}{q}\right)^2$$

– Get the average sigma of above  $\sigma$  in each  $\theta$ 





- Analysis 1 (previous method) for simulation 1
  - Get the number of photoelectron generated 511 [keV] and energy resolution at 511 [keV]





- Analysis 2 for simulation 2
  - Get the real position of interaction from "LXeHits"
  - Get the reconstructed position by center of gravity method
  - Plot the difference of *u* and
     *v*
  - Project 2D histogram to X and Y
  - Calculate the σ by twice gauss fitting





1/-

(real position of interaction)

#### Analysis 3 for simulation 2 •

- Divided volume by 36 (6 x 6) areas —
- Histograms shows the comparing result about *u* and *v* —





- Analysis 3 for simulation 2
  - Calculate the mean and sigma of each areas by GetMean() and GetRMS() of ROOT function

$$\sigma = RMS = \sqrt{\frac{\sum_{i} q_{i} x^{2}}{q} - \left(\frac{\sum_{i} q_{i} x}{q}\right)^{2}}$$

$$Mean = \frac{\sum_{i} q_{i} x}{q}$$

- Plot sigma and mean of each area
- Evaluate the volume and compare the result of each other





















- Analysis 1
  - Number of photoelectron and energy resolution
  - each aperture ratio and PMT





- Analysis 1 conclusion
  - Both  $\sigma$  of u and v became worse than old geometry
    - Decrease the Number of photoelectron (less than half)
  - Especially *u*, σ has better value in case A.R. has a larger value
  - Got the 1.5 3 times number of photoelectron in 2" PMT geometry, comparing with one of 1"PMT
    - 2" PMT has better quantum efficiency (1.16 times) and larger detecting area (1.65 times) than 1" PMT
  - Little improvement in mesh cathode case
  - Energy resolution was improved 2-7% in 2"PMT and mesh cathode case



• Analysis 2



Sigma [mm]



- Analysis 3
  - 2" PMT, A.R. = 0 model
  - U and W means real position of interaction







- Analysis 3
  - 2" PMT, A.R. = 0 model
  - U and W means real position of interaction



Sigma [mm]



- Analysis 3
  - 2" PMT, A.R. = 0 model
  - U and W means real position of interaction















- Analysis 2 and 3 conclusion
  - Average  $\sigma_u$  and  $\sigma_v$  of one event
    - $\sigma_u = 19.27 + -0.12 \text{ [mm]}, \sigma_v = 15.14 + -0.09 \text{ [mm]}$
  - Mean value depends the interaction position
    - Center of gravity method should be modified or need calibration
  - Need more statistics
  - Need more study for fluctuation of sigma

#### Conclusion



- Modified GATE code to record hit information in LXe
- Updated some macros of GATE and the geometry of XEMIS2
- Made the program which compares reconstructed position with real position and analyzes σ and mean in each area
  - Need the other method to calculate the mean of u and v

#### Future



- Instead of v, test φ resolution (angle resolution)
- Study the fluctuation of volume
- Study the relation between D and w
- Simulate the case other materials are used for cathode or electrode



#### Merci beaucoup.





